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## PATENT APPLICATION

Atty. Docket No.: 2522-044 Serial No.: 10/688,017  
Applicant: Byung-Jun PARK and Ji-Young KIM  
Filing Date: October 16, 2003 Group: 2822

INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)U.S. PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
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FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
<u>KPD</u>	_____	1999-84959	Dec. 6, '99	Korea	Gyu-Pil Lee, et al.
<u>KPD</u>	_____	2002-58285	Jul. 12, '02	Korea	Min Huh

OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, etc.</u>
<u>KPD</u>	_____	English language abstract of Korean Publication No. 1999-84959
<u>KPD</u>	_____	English language abstract of Korean Publication No. 2002-58285

Examiner: John K. DwyerDate Considered: 1/11/2006

IDS 10/28/2005

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 FORM PTO-1449 (Modified)
U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
KPD		6,211,091	Apr. 3, 01	Lien et al.		
		2001/0005623	Jun. 28, 01	Kim et al.		
		2002/0186601	Dec. 12, 02	Lee et al.		
		2003/0003718	Jan. 2, 03	Park et al.		
		2003/0022486	Jan. 30, 03	Wu		

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OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)

Examiner: J. HanleyDate Considered: 1/11/2006